PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q90565 Hong-sik PARK, et al. Appln. No.: 10/552,351 Group Art Unit: 2812 Confirmation No.: 2396 Examiner: Elias ULLAH Filed: October 7, 2005 METHOD OF FABRICATING SEMICONDUCTOR PROBE WITH RESISTIVE TIP For: RESPONSE UNDER 37 C.F.R. § 1.111 MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir: Responsive to the outstanding Office Action of June 1, 2007, please consider Applicants' remarks as follows. TABLE OF CONTENTS REMARKS......2